Docket Number (Optional) Application Number 134082-1 10/675,109 INFORMATION DISCLOSURE CITATION Applicant(s) JAN 0 2 2004 (Ost several sheets if necessary) Ji-Cheng Zhao et al. Group Art Unit Filing Date NYA September 30, 2003 U.S. PATENT DOCUMENTS RADEMARY FILING DATE CLASS SUBCLASS NAME EXAMINER DATE DOCUMENT NUMBER REF IF APPROPRIATE INITIAL ~, ٠. کیایتان -_: ., : : ::7 4... FOREIGN PATENT DOCUMENTS Translation CLASS SUBCLASS DATE COUNTRY REF DOCUMENT NUMBER YES 7.7. ٠. ٠., OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) Jaramillo, Thomas F. et al., "High-Throughput Screening System for Catalytic Hydrogen-Producing Materials", J. Comb. Chem, 2002, 4, 17-22. DATE CONSIDERED EXAMINER EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not, considered. Include copy of this form with next communication to applicant.

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